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02975.000131

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kazuo IIZUKA et al.

Application No.: 10/762,481

Filed: January 23, 2004

For: PROJECTION EXPOSURE
APPARATUS

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Examiner: P. B. Kim
Group Art Unit: 2851
Confirmation No.: 4938
January 12, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statements filed March 9, 2004, and September 22, 2005, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the European patent document, the Japanese patent document, the Holbrook et al. article, and the European Search Report are also enclosed.

The cited documents were first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement. Specifically, these documents were cited in a European Search Report dated November 29, 2005, which was forwarded in a Communication mailed December 21, 2005 (copies enclosed), from the European Patent Office in corresponding European patent application number 04 00 1986.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

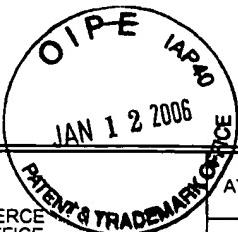
Respectfully submitted,



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SEW/eab



FORM PTO 1449 (<i>modified</i>) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 02975.000131		APPLICATION NO. 10/762,481		
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		APPLICANT Kazuo IIZUKA et al.				
January 12, 2006		FILING DATE January 23, 2004			GROUP 2851	
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS
		US-5,705,299	01/06/1998	Tew et al.	430	5
		US-6,078,381	06/20/2000	Suzuki	355	53
		US-6,545,274 B1	04/08/2003	Morita	250	307
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS
		EP 0 633 506 A1	01/11/1995	Europe		
		2000-208410	07/28/2000	Japan		Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)						
		European Search Report dated November 29, 2005, issued in corresponding European patent appln. no. EP 04 00 1986, forwarded in a Communication dated December 21, 2005.				
		Holbrook, David S., et al. "Microlithography for Large Area Flat Panel Display Substrates," Solid State Technology, Pennwell Corporation, Tulsa, OK, vol. 35, no. 5, May 1, 1992, pp. 166-172.				
EXAMINER			DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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